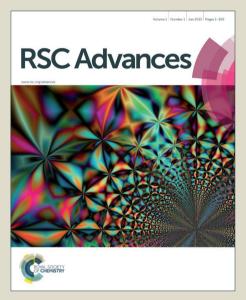


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# Growth, structural and plasma illumination properties of nanocrystalline diamond decorated graphene nanoflakes

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# Abstract

The improvement on the plasma illumination (PI) properties of a microplasma device owing to the application of nanocrystalline diamond decorated graphene nanoflakes (NCD-GNFs) as cathode is investigated. The improved plasma illumination (PI) behavior is closely related to the enhanced field electron emission (FEE) properties of the NCD-GNFs. The NCD-GNFs possess better FEE characteristics with a low turn-on field of 9.36 V/µm to induce the field emission, a high FEE current density of 2.57 mA/cm<sup>2</sup> and a large field enhancement factor of 2380. The plasma can be triggered at a low voltage of 380 V, attaining a large plasma current density of 3.8 mA/cm<sup>2</sup> at an applied voltage of 570 V. In addition, the NCD-GNFs cathode shows enhanced lifetime stability of more than 21 min at an applied voltage of 430 V without showing any sign of degradation, whereas the bare GNFs can last only 4 min. The superior FEE and PI properties for the NCD-GNFs are ascribed to the unique combination of diamond and graphene. Transmission electron microscopic studies reveal that the NCD-GNFs contain nano-sized diamond films evenly decorated on the GNFs. Nanographitic phases in the grain boundaries of the diamond grains form electron transport networks that lead to improvement in the FEE characteristics of NCD-GNFs.

**Keywords:** *nanocrystalline diamond, graphene nanoflakes, field electron emission, plasma illumination, lifetime stability, high resolution transmission electron microscopy* 

# Introduction

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Basically, microplasma based devices symbolize a photonics technology at the connection of plasma science, optoelectronics, and materials science. Such plasma-based devices display pronounced prospective for a broad spectrum of applications in microdisplays, materials synthesis, elemental analysis and detection of environmentally hazardous or poisonous gases or vapors. In the operation of a microplasma device, the stability of the plasma is of great concern.<sup>1–3</sup> The materials with large secondary electron emission efficiency were thus commonly used as cathode for these devices. However, the robustness (the lifetime) of the devices is a characteristic, which is of even more importance in device applications. Diamond and graphene being distinctive allotropes of carbon with their unique physical and chemical characteristics of these materials have attracted profound scientific and technological interest in recent years.<sup>4-7</sup> Diamond with a strong covalently bonded crystal structure and a high negative electron affinity (NEA) when H-terminated,<sup>8,9</sup> is seen as a candidate for a potential field electron source exhibiting high lifetime and reliability. Additionally, diamond unveils large secondary electron emission efficiency, which is particularly capable for serving as a cathode material in microplasma based devices.<sup>10</sup> Nevertheless, the large band gap (5.5 eV) in diamond considerably hampers the field electron emission (FEE) behavior because of the lack of free electrons necessary for field emission. High-quality field electron emitters entail both a sufficient supply of electrons from back contact materials and effectual transport and efficient emission from the emitting sites.

Graphene is a two-dimensional (2D) honeycomb lattice consisting of hexagonally arrayed sp<sup>2</sup>-bonded carbon atoms.<sup>11</sup> The open surface and sharp edge of graphene create a large aspect ratio thus making it an attractive candidate for FEE applications.<sup>12,13</sup> Recent reports indicate the turn-on field for flat graphene sheets to be high.<sup>14</sup> An alternative configuration is the use of graphene nanoflakes (GNFs) because of an abundant existence of sharp edge planes in GNFs, which can be a high density source of individual field emission sites. The presence of emissive sites in GNFs is particularly useful and relevant for high efficiency graphene based field electron

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emitters.<sup>15</sup> GNFs are made up of vertically stacked 2D graphene sheets which are very much unlike carbon nanowalls associated with highly defective nanostructured graphite.<sup>16</sup> However, the short lifetime and the poor stability of the graphene emitters, in a plasma environment, are major barriers preventing their beneficial integration. Based on the above, we motivate the stable and reliable microplasma devices could be fabricated based on an effective combination of diamond and graphene. In order to fabricate such diamond-graphene hybrid devices, it is important to create diamond/graphene heterostructures. To date, there have only been limited reports regarding the growth of diamond on graphene layers.<sup>17-19</sup> This is primarily due to issues associated with structural and interfacial integration of the materials and the resulting FEE characteristics, which leaves room for reliable improvement.

In this study, nanocrystalline diamond (NCD) grains were decorated on GNFs using a microwave plasma enhanced chemical vapor deposition (MWPECVD) process as a first step towards the fabrication of diamond-graphene hybrid FEE materials as cathode for fabricating microplasma devices. Enhanced plasma illumination (PI) properties were observed. Noticeably, better lifetime stability for the microplasma devices has been accomplished that is interrelated to the FEE behavior of the cathode materials. The promising mechanism for such phenomenon is conversed.

# **Experimental methods**

n-type Si substrates were used to grow GNFs. Prior to growth, the substrates were pretreated with N<sub>2</sub> plasma at 700 W at 40 mbar for 5 min, while the substrate temperature was maintained at 700 °C–900 °C due to bombardment of species in the plasma. The synthesis of GNFs was carried out in a SEKI MWPECVD system, equipped with a 1.5 kW, 2.45 GHz microwave source using CH<sub>4</sub>/N<sub>2</sub> (gas flow ratio=3:2) plasma at 900 W for a duration of 5 min. The samples were allowed to cool under a constant N<sub>2</sub> flow. The conditions used were similar to the ones used in our previous publication.<sup>20</sup> The NCD films were then directly grown on the bare GNFs by using an ASTeX 6500 series MPECVD system in a CH<sub>4</sub>(6%)/H<sub>2</sub>(91%)/N<sub>2</sub>(3%) plasma with a microwave power of 3000 W for 30 min. The pressure and the flow rate were maintained at 20 Torr and 300 sccm, respectively. The samples are here forth referred to as "NCD-GNFs".

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The morphology and the crystalline quality of the samples were examined using scanning electron microscopy (SEM; FEI Quanta 200 FEG microscope) and confocal micro-Raman spectroscopy (Horiba Jobin-Yuan T64000 spectrometer;  $\lambda$ =488 nm and spot size= ~1 µm). The local microstructure and bonding structure of the samples were studied using TEM (JEOL 2100F) and electron energy loss spectroscopy (EELS) (Gatan Enfina), respectively. The FEE properties of the samples were measured in a parallel plate configuration, in which the anode was a Mo rod (2 mm in diameter) and the cathode was the NCD-GNFs. The cathode-to-anode separation was controlled by a micrometer. The FEE current density versus applied field (J<sub>e</sub>-E) characteristics were acquired using a Keithley 2410 electrometer and these were elucidated using the Fowler-Nordheim (F-N) theory.<sup>21</sup> The turn-on field (E<sub>0</sub>) is nominated as the intersection of the straight lines extrapolated from the high-field and low-field segments of the F-N plots, which is ln (J<sub>e</sub>/E<sup>2</sup>) versus 1/E plots.

To investigate the feasibility of using NCD-GNFs materials as cathode for a microplasma device, an indium tin oxide (ITO)-coated glass was used as anode and the NCD-CNFs were used as cathode. The cathode-to-anode separation was fixed with a 1 mm polytetrafluroethylene (PTFE) spacer with a 3 mm diameter opening to form a microcavity. The schematic of the configuration is shown in Fig. 1. The microplasma device was placed in a glass chamber, which was evacuated to reach a base pressure of 0.1 mTorr and then purged with Ar for 10 min. The Ar was channeled into the chamber at a flow rate of 10 sccm and the PI measurements were carried out at pressure of 2 Torr. The plasma was triggered using a direct current voltage source, with a maximum applied voltage of 1000 V and was connected to device through a 500 k $\Omega$  resistor.

### **Results and discussion**

Fig. 2a shows the SEM image of bare GNFs that are flake like structures consisting of randomly interwoven sharp edges with open spaces between them. The TEM analysis of bare GNFs (inset of Fig. 2a) confirms that the flakes are made up of a large number of graphene layers and graphitic edges. The vertically aligned orientation is a unique feature of the MPECVD synthesis route and it provides an excellent structure for an electron emitter.<sup>15</sup> The SEM image of Fig. 2b reveals the NCD material decorates the GNFs with full coverage. The uniqueness in the method lies in obtaining NCD films in the absence of nucleation by seeding or any other

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pretreatments on bare GNFs prior to the growth. It has been proposed that the nucleation of diamond started with the adherence of C-H bonds<sup>22</sup> onto the GNFs, forming defect sites on the sp<sup>2</sup> graphene network.<sup>23,24</sup> The continued hydrogenation of the GNFs will either result in clustering of sp<sup>3</sup> defects or it will increase the density of isolated sp<sup>3</sup>-point defects. The sp<sup>3</sup> defects offer suitable sites for nucleation of carbon nanoparticles. Initially, an amorphous layer is formed,<sup>25</sup> which then undergoes a phase transition into diamond nuclei.<sup>26</sup>

Raman spectroscopy is one of the most powerful non-destructive techniques for characterization of carbon materials. The Raman spectrum of bare GNFs exhibit four major bands, denoted as D (1360 cm<sup>-1</sup>), G (1588 cm<sup>-1</sup>), G' (1620 cm<sup>-1</sup>) (spectrum I of Fig. 3a) and 2D (2727 cm<sup>-1</sup>) band (spectrum I of Fig. 3b).<sup>27–31</sup> Spectrum II in Fig. 3a corresponding to NCD-GNFs contains similar peaks as the GNFs do (cf. spectrum I), i.e., it contains D-, G- and G'-bands and 2D band with exception of  $v_3$  peak at 1539 cm<sup>-1</sup>. Raman analysis of the spectrum II of Fig. 3b), conceivably due to the bond-angle disorder and compressive stress at the sp<sup>2</sup>:sp<sup>3</sup> composite interface.<sup>32</sup> The diamond peak at 1332 cm<sup>-1</sup> is not clearly observed due to the nano-sized diamond grains. The existence of diamond in these materials will be revealed by TEM examinations.

The TEM image shown in Fig. 4a illustrates that NCD films containing diamond grains about tens of nano-meters in size, conformally covering the GNFs. The selective area electron diffraction (SAED) pattern of the NCD-GNFs is shown in the inset of Fig. 4a. Ring-shaped diffraction rings corresponding to the (111), (220) and (311) lattice planes of diamond are perceived, confirming that the nano-sized particles are NCD grains. There is a prominent diffused ring at the center of the SAED pattern, representing the presence of sp<sup>2</sup> bonded carbon (amorphous or graphitic phase). Fig. 4b shows a high resolution TEM (HRTEM) structure image of the NCD-GNFs, corresponding to the designated region 'A' in Fig. 4a. The NCD grains are ~5 nm in size. The Fourier transformed diffractogram (FT<sub>0b</sub>-image) corresponding to the whole structure image in Fig. 4b shows a spotted diffraction pattern arranged in a ring (designated as "d"), which represents the randomly oriented diamond grains. The diffused diffraction pattern located at the center of the FT<sub>ob</sub> image (designated as "g") corresponds to the graphitic (g) phase. The ft<sub>1</sub> image corresponding to large aggregates in region '1' and the ft<sub>2</sub> image corresponding to

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region '2' show a spotted diffraction pattern arranged in a ring, which highlights the presence of the diamond (d) grains. Hence it is evident that the "small-clusters" are nano-sized diamond grains, which are surrounded by nanographitic grain boundaries. In addition, the ft<sub>3</sub> image corresponding to the region '3' highlights the graphitic layers in GNFs. The phase constituents in these NCD-GNFs materials are better illustrated by a composed inverse FT image (Fig. 4c), which was the superposition of the inversed ft images corresponding to diamond and those corresponding to graphite diffraction spots (yellow and green circles in the inset ft pattern of Fig. 4c, respectively). In this figure, it is evident that the materials encasing the GNFs consist of nanodiamond grains, which are evenly distributed in nanographitic clusters.

EELS spectra were recorded in the carbon K-edge region of NCD-GNFs to explicitly discriminate between the different carbon materials for instance diamond, graphite and amorphous carbon.<sup>33</sup> To facilitate the comparison, core-loss and plasmon-loss EELS spectra of the bare GNFs were also included (spectra I of Fig. 4d and 4e, respectively). The core-loss EELS spectrum of bare GNFs contains a  $\pi^*$ -band near 284.5 eV and a band near 289 eV (spectrum I of Fig. 4d). In contrast, the core-loss EELS spectrum of NCD-GNFs, contains a sharp peak at 292 eV ( $\sigma^*$ -band) and a dip in the vicinity of 302 eV, which are the typical EELS signals of sp<sup>3</sup>bonded carbon, besides a small hump, representing sp<sup>2</sup>-bonded carbon (285 eV,  $\pi^*$ -band) (spectrum II of Fig. 4d). In contrast, in Fig. 4e, plasmon-loss EELS spectrum of bare GNFs contains a broad peak near  $\omega_g \sim 27$  eV (spectrum I), which corresponds to the graphitic phase,<sup>34–37</sup> whereas that of NCD-GNFs (spectrum II) contains a  $\omega_{d1}$  peak near 23 eV and a shoulder  $\omega_{d2}$  near 33 eV with  $\omega_{d1}/\omega_{d2}$  ratio slightly larger than  $1/\sqrt{2}$ , which implies that there exists a  $\omega_{a-C}$  peak near 22 eV corresponding to an amorphous carbon (a-C) phase.<sup>34–37</sup> These EELS characteristics are in concurrence with the TEM microstructural observations. Hence, it is evident from the TEM and EELS studies that the NCD films are conformally decorating the GNFs and each NCD grain is surrounded by nanographitic (or a-C) grain boundaries.

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The FEE measurements were carried out on the bare GNFs and the NCD-GNFs, and the results are shown in Fig. 5 with the inset showing the F-N plot. The NCD-GNFs possess slightly better FEE properties than the bare GNFs. While the FEE process of the bare GNFs can be turned on at  $(E_0)_{GNFs}$ =15.0 V/µm, attaining FEE current density of  $(J_e)_{GNFs}$  = 1.24 mA/cm<sup>2</sup> at an applied field of 24.0 V/µm (curve I of Fig. 5), the decoration of NCD films on GNFs markedly

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enhanced the EFE properties of the materials. The NCD-GNFs can be turned on at a smaller field, i.e.  $(E_0)_{NCD-GNFs} = 9.36 \text{ V/}\mu\text{m}$ , and exhibit higher FEE current density of  $(J_e)_{NCD-GNFs}=2.57 \text{ mA/cm}^2$  at an applied field of 24.0 V/ $\mu$ m (curve II of Fig. 5). The field enhancement factor ( $\beta$ ) corresponding to the bare GNFs and the NCD-GNFs was calculated from the slope of the F-N plots, which is shown as inset in Fig. 5. The  $\beta$ -factors were estimated to be  $(\beta)_{GNFs}=1560$  and  $(\beta)_{NCD-GNFs}=2380$  for bare GNFs and NCD-GNFs, respectively. These FEE parameters are listed in Table 1. Therefore, the coating of NCD on GNFs does provide a benefit for the FEE emitters.

The performance of the microplasma devices, with NCD-GNFs as cathodes, was then investigated for using high FEE materials as cathode for enhancing their PI behavior. Fig. 6 shows a series of photographs of the PI intensity of the microplasma devices, which utilized the bare GNFs (image series I of Fig. 6) and NCD-GNFs (image series II of Fig. 6) as cathode materials. The intensity of the plasma increases monotonically with the applied voltage. The bare GNFs based microplasma devices need 400 V (breakdown field of Eb=400 V/mm) to trigger the plasma, while the NCD-GNFs based microplasma devices can be triggered by a voltage=380 V (E<sub>b</sub>=380 V/mm). The PI characteristics are better illustrated by the variation of the plasma current density  $(J_{PI})$  versus E, which was plotted in Fig. 7a. The bare GNFs based microplasma devices (curve I of Fig. 7a) show a J<sub>PI</sub> value of 3.3 mA/cm<sup>2</sup> at an applied voltage of 570 V, whereas the J<sub>PI</sub> achieves 3.8 mA/cm<sup>2</sup> at the same applied voltage for the devices using NCD-GNFs as cathode (curve II of Fig. 7a). The PI characteristics of bare GNFs and NCD-GNFs are also listed in Table 1. What is intriguing is that NCD-GNFs based microplasma devices not only show better PI behavior than the bare GNFs cathode-based microplasma devices, they also exhibit superior robustness, compared with the bare GNFs-based ones. To evaluate the stability of the GNFs and the NCD-GNFs cathode microplasma devices, the  $J_{PI}$  was monitored over a long period with a constant applied voltage of 430 V (Fig. 7b), where the bare GNFs-based microplasma devices exhibit 0.8 mA/cm<sup>2</sup> and the bare NCD-GNFs-based microplasma devices exhibit 1.3 mA/cm<sup>2</sup> plasma current density. The JPI value of the bare GNFs-based microplasma devices decayed very fast. It occurred after 4 min (240 s) of plasma ignition (curve I of Fig. 7b). The GNFs are completely damaged after lifetime measurements (inset I of Fig. 7b). Interestingly, for NCD-GNFs based devices, the plasma current is upheld for a period over 23 min (1380 s)

(curve II of Fig. 7b). The NCD-GNFs can survive even after 23 min of plasma discharge (inset II of Fig. 7b), illustrating the higher robustness of these devices.

It should be noted that the electric field required to trigger the Ar plasma (380–400 V/mm) is much smaller than the  $E_0$  for inducing the FEE process (i.e., 15.0–15.2 V/µm) for both the GNFs and the NCD-GNFs. It is not straightforward to understand how the better FEE properties of NCD-GNFs materials can enhance the PI behavior of the corresponding microplasma devices. Usually, the Ar plasma can be triggered whenever electrons emitted from the cathodes reach a kinetic energy larger than the ionization energy of the Ar species (14.7 eV). After the initiation of the Ar plasma, the NCD-GNFs (or GNFs) cathode materials mainly serve as good source of secondary electrons for maintaining the ignition of the plasma. Better FEE properties of the NCD-GNFs compare to GNFs seems showing insignificant superiority in maintaining the plasma in the microplasma devices. However, when the plasma in the devices was ignited, a sheath is formed in the vicinity of the cathode, which is of the order of tens of microns.<sup>38</sup> The applied voltage will be fully exerted at the sheath. The electric field experienced by the cathode will increase abruptly to around 40 V/ $\mu$ m, which is markedly larger than the E<sub>0</sub>-value for turning on the FEE process of the cathode materials. Therefore, superior FEE properties for the cathode materials might provide the larger FEE current density for the microplasma devices. Apparently, both the superior FEE properties and higher secondary electron emission efficiency for the NCD-GNFs contribute to the better PI performance of the microplasma devices, which are based on the NCD-GNFs as cathode, as compared to bare GNF-based ones.

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Now the question that arises is, how does the microstructure support the electron transport mechanism of NCD-GNFs for obtaining these enhanced FEE and PI properties? It is observed from TEM studies (cf. Fig. 4) that GNFs are decorated by NCD films and each diamond grain in the NCD films is surrounded by nanographitic grain boundaries. Based on the TEM observations, the mechanism for the improved FEE behavior of the NCD-GNFs can be explained as follows: first, the good electron transport properties of GNFs supplies sufficient electrons to the NCD region. The nanographitic phases present in the grain boundaries of NCD grains, which served as the emitting surface. Then the electrons are emitted to vacuum without any difficulty as the diamond H-terminated surface has a NEA in nature.<sup>5,6</sup> Additionally, the vertically aligned

structure of GNFs facing the anode can be considered as an additional reason for improving the FEE and PI properties of the NCD-GNFs.

# Conclusions

A facile and reproducible way of decorating GNFs with NCD materials results in superior functioning and improved lifetimes of microplasma devices compared to bare GNFs as cathodes. Detailed structural characterizations through TEM reveal the GNFs are homogeneously covered with NCD grains possessing nanographitic grain boundaries. As a result, the microplasma devices based on NCD-GNFs cathodes shows better PI characteristics due to enhanced FEE properties of the cathode materials. More importantly, the J<sub>PI</sub> of 1.31 mA/cm<sup>2</sup> (a constant applied voltage of 430 V) is maintained for a period over 23 min, displaying better plasma lifetime stability for NCD-GNFs based microplasma devices, as compared to that of the bare GNFs (plasma lifetime stability of 4 min). These results point to the possibility of using NCD-GNFs as potential candidates for applications in microplasma devices.

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 Table 1 Field electron emission and plasma illumination properties of bare GNFs and NCD-GNFs.

	Field Electron Emission (FEE)			Plasma Illumination (PI)		
Samples	E <sub>0</sub>	J <sub>e</sub>	β	E <sub>b</sub>	$J_{\rm PI}$	$ au_{\mathrm{PI}}$
	(V/µm)	(mA/cm <sup>2</sup> ) @ 24.0 V/µm		(V/mm)	(mA/cm <sup>2</sup> ) @ 500 V	(min) @ 430 V
Bare GNFs	15.0	1.24	1560	400	3.1	4
NCD-GNFs	15.2	2.57	2380	380	3.6	23

E<sub>0</sub>: the turn-on field for FEE process that was designated as the interception of the lines extrapolated from the high-

field and low-field segments of the F-N plots.

- Je: the FEE current density evaluated at the applied field designated.
- $\beta$ : the field enhancement factor.

E<sub>b</sub>: the breakdown field for PI process.

 $J_{PI}$ : the PI current density evaluated at the applied voltage of 500 V.

 $\tau_{PI}$ : the lifetime stability tested under the applied voltage of 500 V.

## Figure captions

Fig. 1 Schematic of the microplasma device measurement.

**Fig. 2** SEM micrographs for (a) bare GNFs, where the inset shows the corresponding TEM micrograph and (b) NCD-GNFs.

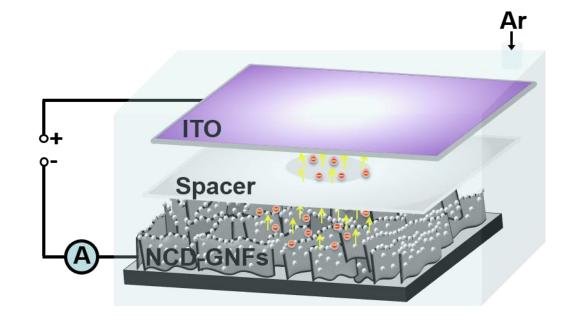
Fig. 3 (a) and (b) Confocal micro-Raman spectra for I. bare GNFs and II. NCD-GNFs.

**Fig. 4** (a) TEM micrograph for NCD-GNFs with the inset showing the selective area electron diffraction (SAED) pattern, (b) HRTEM image of NCD-GNFs of the designated region 'A' in Fig. 4a. The inset  $FT_{0b}$  shows the Fourier-transformed diffractogram corresponding to the entire structure images in Fig. 4b, whereas the ft-images corresponding to the regions marked '1–3' in the HRTEM image are shown in the insets ft<sub>1</sub>–ft<sub>3</sub>, respectively, to illustrate the presence of diamond, nanographite and graphene phases, (c) inverse Fourier-transformed image corresponding to Fig. 4b, (d) core-loss and (e) plasmon-loss EELS spectra, where I. is for bare GNFs and II. is for NCD-GNFs.

**Fig. 5** Field Electron emission (FEE) current density ( $J_e$ ) as a function of applied field (E) of I. bare GNFs and II. NCD-GNFs emitters. The inset shows the corresponding Fowler-Nordheim plots, i.e., ln ( $J_e/E^2$ )-1/E plots).

**Fig. 6** Photographs of plasma illumination (PI) characteristics of microplasma devices using I. bare GNFs and II. NCD-GNFs as cathode.

**Fig. 7** (a) Plasma current density  $(J_{PI})$  versus applied field (E) and (b) plasma lifetime measurements of a microplasma device, which utilized ITO coated glass as anode and using either I. bare GNFs or II. NCD-GNFs as cathode materials, at an applied voltage of 430 V. The insets show the SEM micrographs of the I. GNFs and II. NCD-GNFs cathode materials used in the microplasma devices after the plasma discharge.





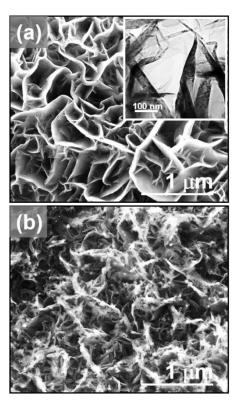


Fig. 2

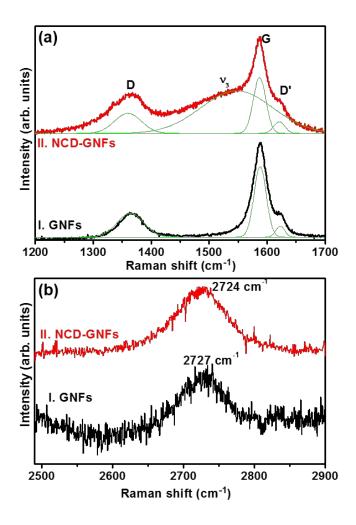
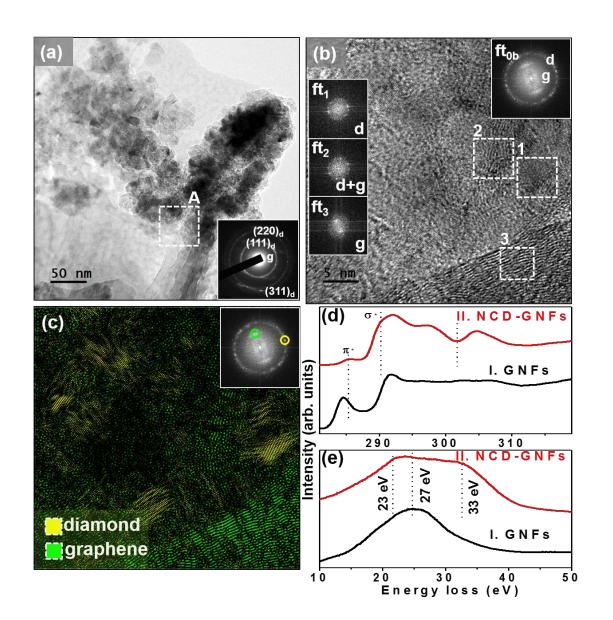


Fig. 3





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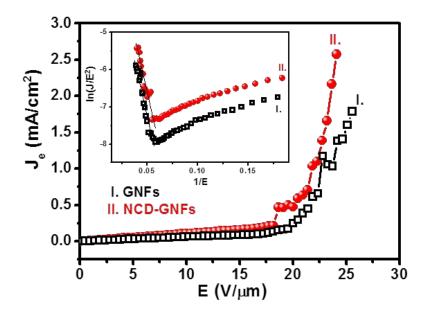


Fig. 5

I. GNFs		II. NCD-GNFs			
360 V	460 V	360 V	460 V		
380 V	480 V	380 V	480 V		
400 V	500 V	400 V	500 V		
420 V	520 V	420 V	520 V		
440 V	540 V	440 V	540 V		

Fig. 6

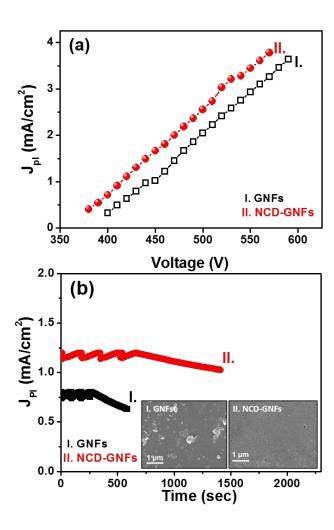
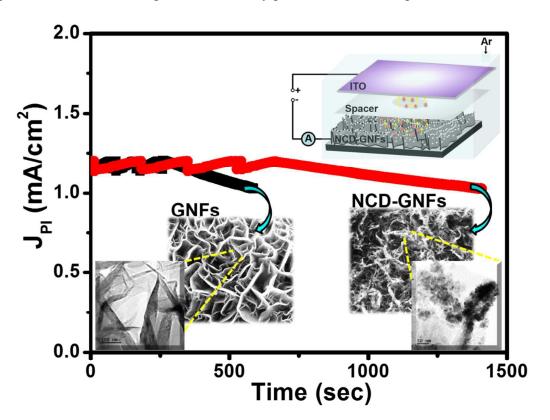


Fig. 7

# **Graphical abstract**

Decorating graphene nanoflakes with nanocrystalline diamond shows superior functioning for microplasma devices with long lifetime stability plasma illumination performances.



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